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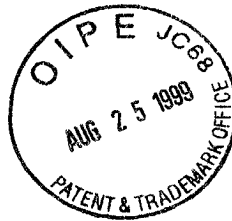
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KIRA, et al.

Serial Number: 08/897,953

Filed: July 24, 1997



Group Art Unit: 2814

Examiner: D. Graybill

For: METHOD AND SYSTEM FOR FABRICATING SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR §1.111

Assistant Commissioner of Patents
Washington, D.C. 20231

August 25, 1999

Sir:

In response to the Office Action dated March 25, 1999 please amend the above-captioned patent application as follows:

IN THE DRAWINGS:

Applicants respectfully submit herewith a Request for Approval of Drawing Corrections along with proposed drawing corrections to Fig. 3, marked in red ink.

Applicants respectfully request that the proposed drawing corrections submitted herewith be approved by the Examiner, and that the outstanding objections to the drawings be withdrawn.

IN THE CLAIMS:

Amend claims 11-12 and 15-17 as follows:

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